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8/11/03

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **HATTORI, Kazuhiro**

Serial No.: **09/816,784**

Filed: **March 26, 2001**

RECEIVED
AUG 12 2003
TC 1700

Group Art Unit: **1765**

Examiner: **Lan Vinh**

P.T.O. Confirmation No.: **5542**

For: **DRY ETCHING METHOD, MICROFABRICATION PROCESS AND DRY ETCHING MASK**

AMENDMENT UNDER 37 CFR §1.111

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

August 8, 2003

Sir:

In response to the Office Action dated **April 8, 2003**, extended to August 8, 2003 by a one (1) month Petition for Extension of Time, please amend the above-identified application as follows: